



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi SERA

Group Art Unit: 2813

Application No.: 10/826,366

Examiner: C. RODGERS

Filed: April 19, 2004

Docket No.: 119209

For: METHOD FOR MAKING THIN-FILM SEMICONDUCTOR DEVICE, THIN-FILM SEMICONDUCTOR DEVICE, METHOD FOR MAKING ELECTRO-OPTIC APPARATUS, ELECTRO-OPTIC APPARATUS, AND ELECTRONIC APPARATUSES

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 2, 2006 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.